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AUTOMATED LASER SPECKLE INTERFEROMETRY DISPLACEMENT CONTOUR ANA--ETC(U)  
JUL 79 J A SCHAEFFEL

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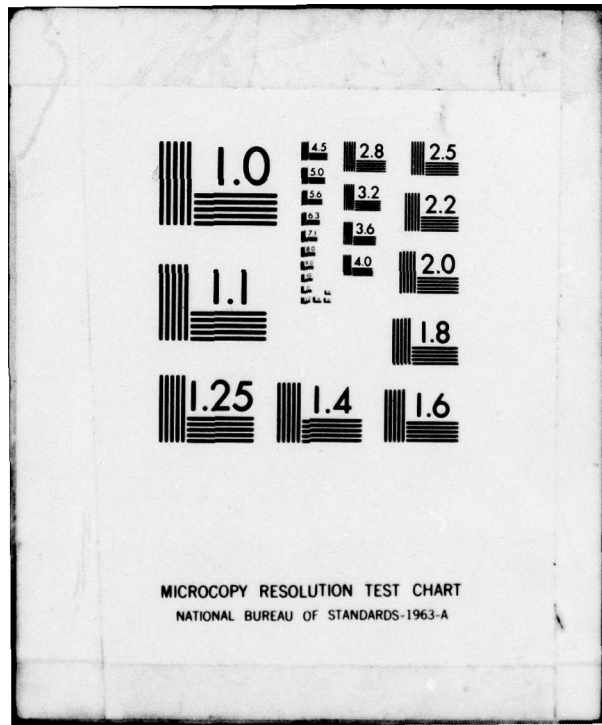
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TECHNICAL REPORT T-79-71

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**AUTOMATED LASER SPECKLE  
INTERFEROMETRY DISPLACEMENT CONTOUR  
ANALYZER**

John A. Schaeffel, Jr.,  
Technology Laboratory

2 July 1979

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**U.S. ARMY MISSILE COMMAND**

*Redstone Arsenal, Alabama 35809*

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20. ABSTRACT (Continue on reverse side if necessary and identify by block number) This work presents a new technique and experimental equipment to analyze Young's Fringe speckle interferograms. A new method using an off-axis optical photodetector was developed for generating displacement contour maps of bodies when deformed under load. Laser speckle interferograms are made of the deformed body and analyzed with a special displacement contouring computer analyzer. Interferograms of a flawed composite tube were analyzed by the system and are presented in the work. Currently operating at about 20% of its maximum rated speed, the system can analyze 5000 data points in less than four minutes. This		

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20. report presents both the theory and hardware which may be utilized to generate displacement contour maps of deformed bodies.



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## 1. INTRODUCTION

The analysis of laser speckle interferograms is often a tedious and time consuming task. Many attempts have been made toward automating the analysis process with excellent success. The only major drawbacks have been in the time required and cost effectiveness of the process. With the idea of reducing cost, decreasing processing time and increasing reliability a new technique was sought for interpreting speckle interferograms. The new method utilizes an off-axis photosensor element coupled to a mini-computer to achieve these goals.

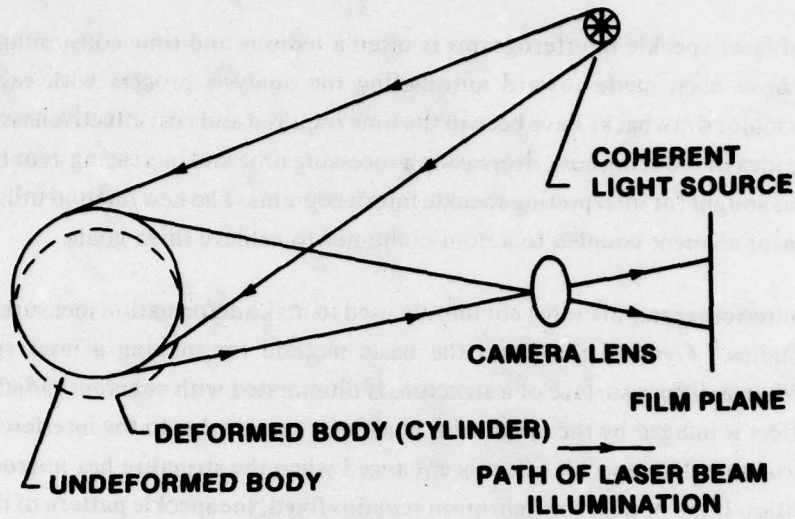
Laser speckle interferograms are most commonly used to make deformation measurements of deformable bodies.<sup>1</sup> *Figure 1* illustrates the basic method for making a laser speckle interferogram. When a diffuse surface of a structure is illuminated with coherent radiation, a grainy speckle effect is imaged by the eye or film plane of a camera due to the interference of light from the structure. This speckle effect is enhanced when the structure has microscopic surface irregularities. If the optical configuration remains fixed, the speckle pattern of the test object may be recorded on the film plane of a camera. Further, if the structure is deformed, the speckle points shift with the deformation and a second exposure of the deformed speckle pattern can be made.

Using a technique of double exposure, speckle interferograms of a structure are normally made by photographing the speckle pattern in a deformed and undeformed configuration. A beam of laser light is then passed through a region of the double exposure where the local deformation is desired. As the beam passes through the film, the deformed and undeformed speckle recorded there diffract the laser light and cause an interference effect on a viewing screen. A diffraction halo modulated by light and dark bars of light is produced where the distance  $2d$  between bars is inversely proportional to the distance between the undeformed and deformed speckle on the film plane. A normal to the light and dark bar pattern indicates the axis of deformation of the speckle. The theory to be developed assumes that the deformation region illuminated by the laser beam in reconstruction is uniform and that the linear optical theory is applicable.<sup>2</sup>

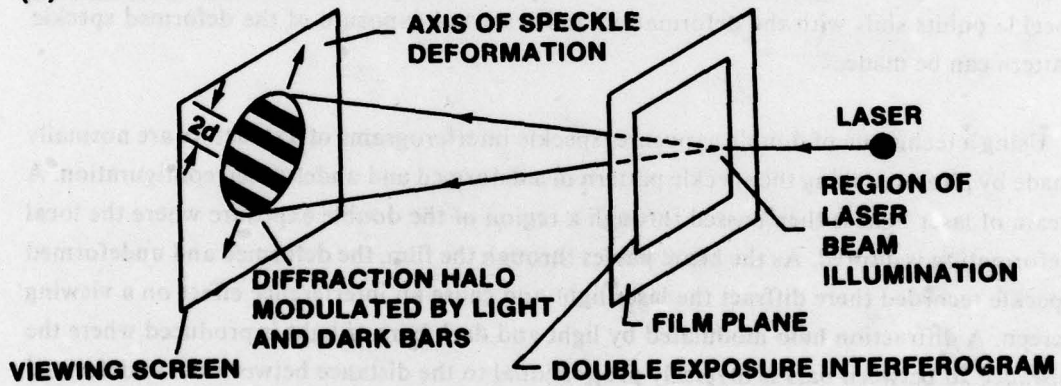
Although the laser speckle interferograms can be made rather quickly, the analysis time of a single illuminated point can be very significant, i.e., several seconds. When a full field analysis is required, the time limitation can be severe if several thousand points of deformation data are

1. J.A. Schaeffel, *Acoustical Speckle Interferometry*, US Army Missile Research and Development Command, Redstone Arsenal, Alabama, Technical Report T-79-39, 22 March 1979.
2. J.A. Schaeffel, B.R. Mullinix, W.F. Ranson, and W.F. Swinson, *Computer Aided Optical Nondestructive Flaw Detection System for Composite Materials*, US Army Missile Research and Development Command, Redstone Arsenal, Alabama, Technical Report T-78-5, 26 September 1977.

**(A) FORMATION PROCESS**



**(B) RECONSTRUCTION PROCESS**



**Figure 1. Laser speckle interferometry configuration.**

needed. Therefore, a rapid low-cost device is needed which can generate contours of constant displacement over a full-field interferogram.

## 2. THEORETICAL DEVELOPMENT

Figure 2 illustrates the reconstructed diffraction halo modulated by light and dark bars of light. From the linear theory,<sup>2</sup> the displacement in the  $\theta$  direction of a point on the body is given as:

$$u_{\theta} = \frac{S\lambda f}{2d} \quad (1)$$

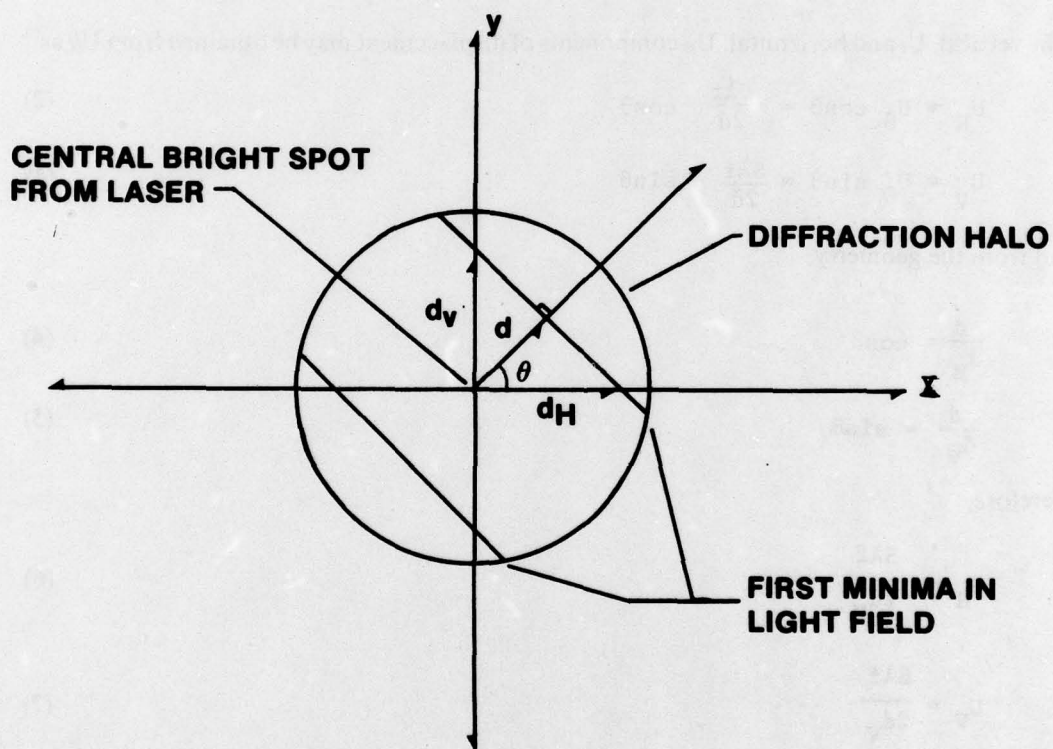


Figure 2. Diffraction halo geometry.

where,

$S \equiv$  film scale factor (magnification ratio).

$\lambda \equiv$  wavelength of laser illumination source.

$f \equiv$  distance from interferogram to analyzer screen.

$d \equiv$  distance from central bright spot to first minima.

$U_{\theta} \equiv$  displacement of the point illuminated by the laser on the object in the  $\theta$  direction.

The vertical,  $U_V$  and horizontal,  $U_H$  components of displacement may be obtained from  $U_{\theta}$  as:<sup>3</sup>

$$U_H = U_{\theta} \cos\theta = \frac{S\lambda f}{2d} \cos\theta \quad (2)$$

$$U_V = U_{\theta} \sin\theta = \frac{S\lambda f}{2d} \sin\theta \quad (3)$$

and from the geometry,

$$\frac{d}{d_H} = \cos\theta \quad (4)$$

$$\frac{d}{d_V} = \sin\theta \quad (5)$$

therefore,

$$U_H = \frac{S\lambda f}{2d_H} \quad (6)$$

$$U_V = \frac{S\lambda f}{2d_V} \quad (7)$$

The optical configuration of *Figure 3* shows a photodetector placed off-axis a distance  $X$  from the laser central bright spot and in the field of the diffraction halo. The photodetector senses the light intensity. Whenever a minima in intensity is detected, the fringe order at the illumination point is an integral number  $n = 1, 2, 3, \dots$  in value.

3. J.A. Schaeffel, *Lab Notebook 7232*, US Army Missile Research and Development Command, Redstone Arsenal, Alabama, 10 November 1978.

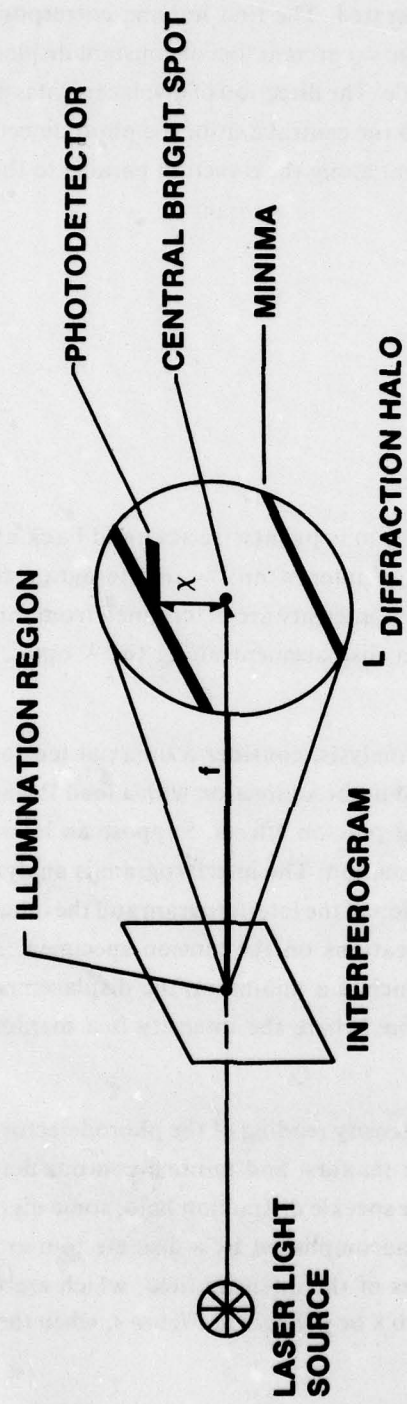


Figure 3. Photodetector optical geometry.

By moving the interferogram in a raster fashion and recording the intensity at each point, contours of constant  $n$  are generated. The first minima corresponds to  $n = 1$ , the second minima  $n = 2$ , etc. These contours represent loci of constant displacement on the body from which the interferogram was made. The direction of displacement is parallel to the axis formed from the central bright spot and the central axis of the photodetector. Once  $n$  is known at a particular point, the displacement along the direction parallel to the  $X$  axis is given as:

$$U_X = n \left\{ \frac{S\lambda f}{2X} \right\} = n\nu \quad (8)$$

where,

$$\nu = \frac{S\lambda f}{2X} \quad (9)$$

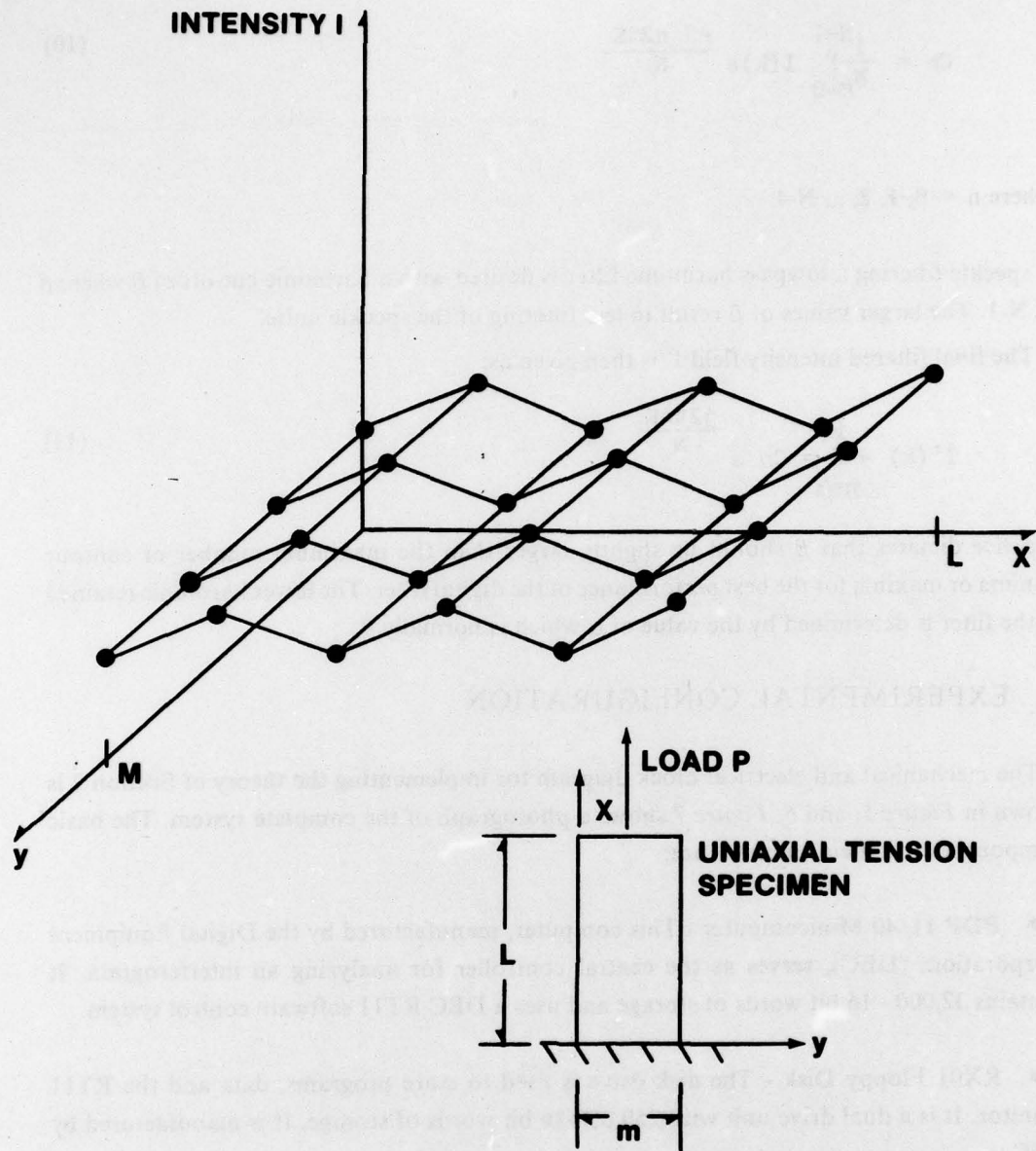
an optical geometrical constant.

In operation the interferogram is pointwise scanned back and forth in front of the photodetector. For each point of interest on the interferogram the intensity is recorded. Contours of minima and maxima intensity are determined from this record. These contours correspond to lines of constant displacement along the  $X$  optical axis as determined by Equation 8.

To illustrate the method of analysis, consider a uniaxial tension specimen as shown in *Figure 4*. The specimen is loaded in the  $x$  direction with a load  $P$  which causes a deformation parallel to the  $x$  axis neglecting poisson effects. Suppose an interferogram is made of the structure before and after deformation. The interferogram is analyzed with a photodetector offset a distance  $X$  in the  $x$  direction of the interferogram and the intensity is shown plotted as a function of  $x$  and  $Y$  for 24 locations on the tension specimen. At each location on the interferogram intensity plot which is a minimum, the displacement is an integral number  $n = 0, 1, 2, \dots$  of  $\nu$ . At locations where the intensity is a maximum the displacement is  $n = 1/2, 3/2, 5/2, \dots$  of  $\nu$ .

In a practical situation the intensity reading of the photodetector is digitized and stored in digital form by a computer for maxima and minima contour determinations. Due to the inherent noise found in the laser speckle diffraction halo, some digital filtering of the optical signal is desired. This may be accomplished by a discrete fourier transform (DFT) of the intensity field. Given  $N$  samples of the intensity field, which are uniformly separated and collinear along an axis parallel to  $x$  or  $y$ , shown in *Figure 4*, when the frequency domain of the transformed field is given as:<sup>4</sup>

4. J.A. Betts, *Signal Processing Modulation and Noise*, American Elsevier Publishing Company, Inc., New York, 1971.



**Figure 4. Intensity plane configuration for uniaxial test specimen.**

$$C_n = \frac{1}{N} \sum_{K=0}^{N-1} I(k) e^{-j \frac{n2\pi K}{N}} \quad (10)$$

where  $n = 0, 1, 2, \dots, N-1$ .

In speckle filtering a lowpass harmonic filter is desired with a harmonic cut-off of  $\beta$  where  $\beta < N-1$ . The larger values of  $\beta$  result in less filtering of the speckle noise.

The final filtered intensity field  $I'$  is then given as:

$$I'(k) = \sum_{n=\alpha}^{\beta} C_n e^{j \frac{2\pi n k}{N}} \quad (11)$$

Practice dictates that  $\beta$  should be slightly larger than the maximum number of contour minima or maxima for the best performance of the digital filter. The lower harmonic retained in the filter is determined by the value of  $\alpha$  which is normally 0.

### 3. EXPERIMENTAL CONFIGURATION

The mechanical and electrical block diagram for implementing the theory of Section 2 is shown in *Figure 5*, and *6*. *Figure 7* shows a photograph of the complete system. The basic components and their functions are:

- PDP 11/40 Minicomputer - This computer, manufactured by the Digital Equipment Corporation, (DEC), serves as the central controller for analyzing an interferogram. It contains 32,000 - 16 bit words of storage and uses a DEC RT11 software control system.
- RX01 Floppy Disk - The disk drive is used to store programs, data and the RT11 monitor. It is a dual drive unit with 250,000-16 bit words of storage. It is manufactured by DEC.
- DECWRITER - This is the typewriter input-output port for the computer. It is a 30 character per second unit used to input scan parameters for analyzing an interferogram and printing the results of the scanning process. It is manufactured by DEC.
- AR11 - This unit is the analog input port manufactured by DEC. It is used to digitize the photodetector intensity signal. The unit features a 16-channel A/D converter with an input

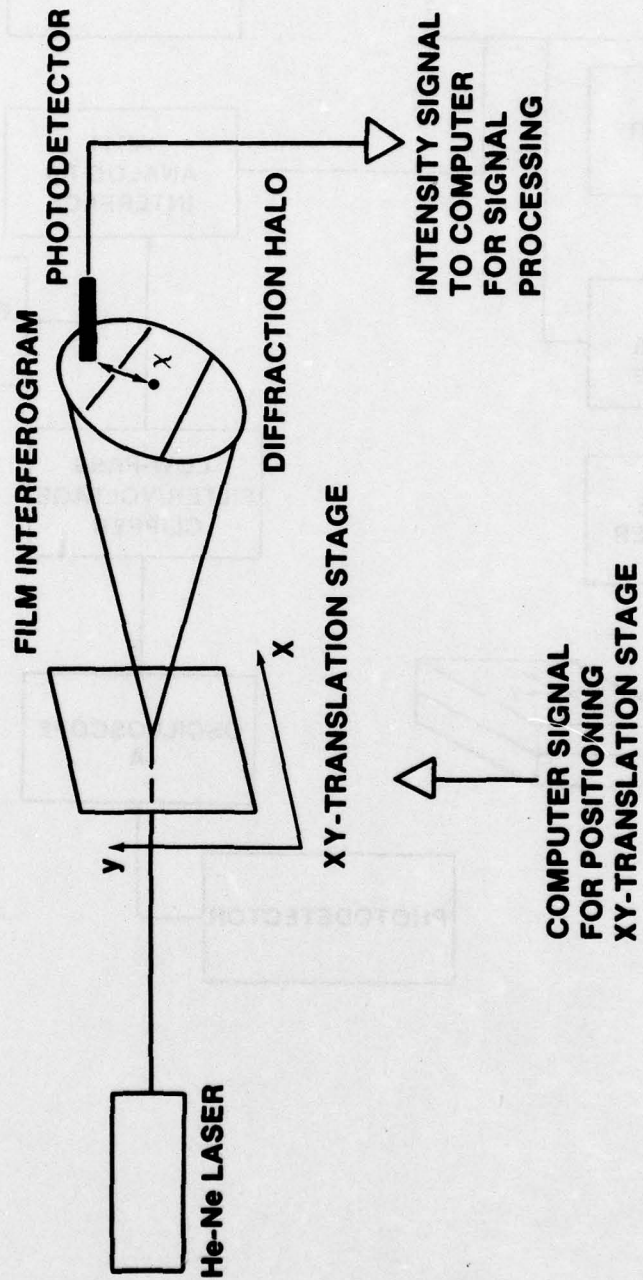
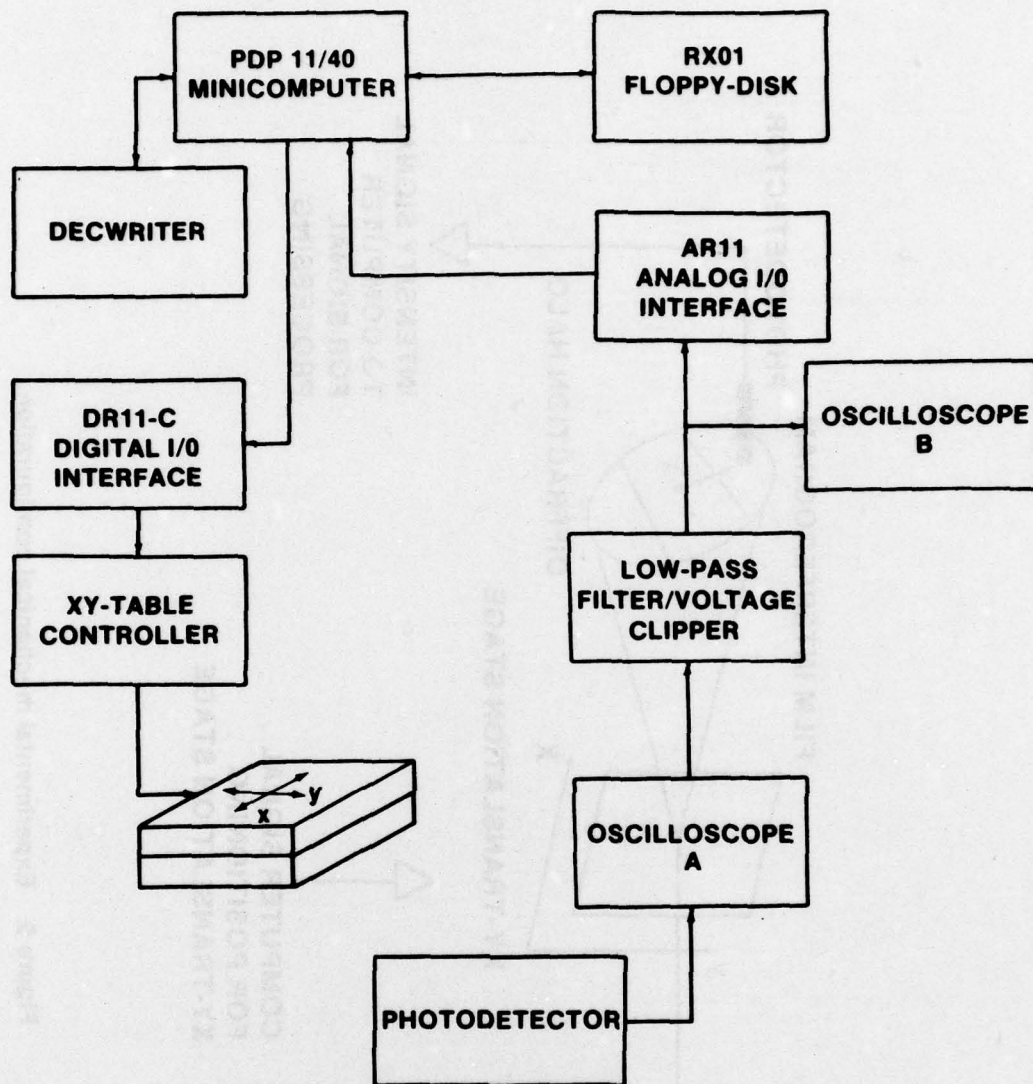
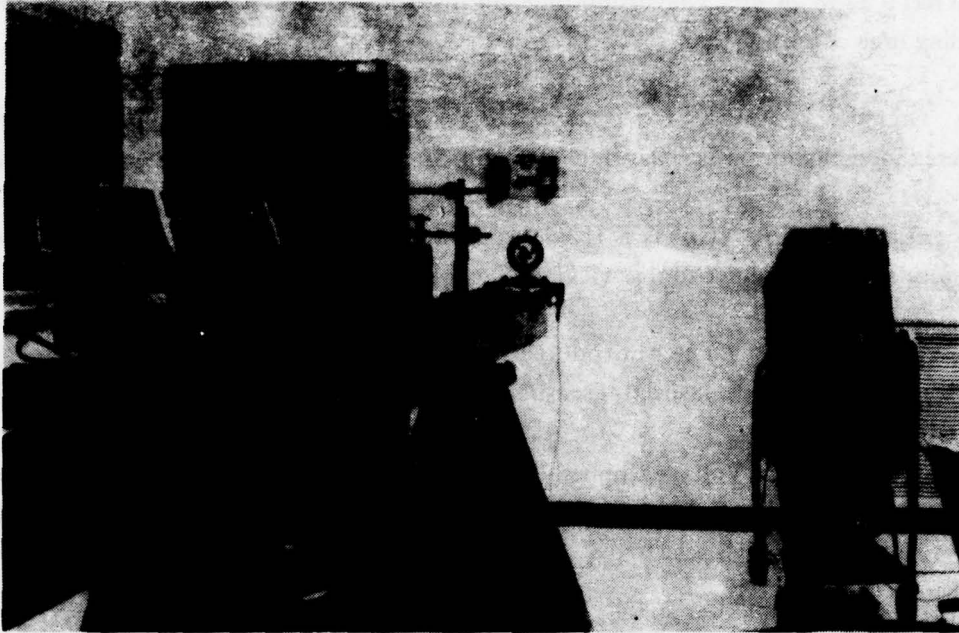


Figure 5. Experimental mechanical configuration.



**Figure 6. Experimental electrical configuration.**



**Figure 7 (a). Optical Bench Configuration.**



**Figure 7 (b). Computer System.**

voltage range of 0 to + 5 V, a resolution of 10 bits, and an accuracy of  $\pm 0.1\%$  of full scale. It also has a 22 to 24  $\mu\text{sec}$  conversion time, an input impedance of 10 M $\Omega$  and a maximum settling time of 8 $\mu\text{sec}$ .

- **Oscilloscope A** - This is a Tektronix Company Model 549 oscilloscope with a type W differential comparator used as a high gain amplifier to amplify the photodetector signal.

- **Oscilloscope B** - This is a Hewlett-Packard Model HP1700B oscilloscope used to monitor the input voltage to the AR11 A/D converter.

- **Photodetector** - The photodetector selected is a Spectra Physics Model 401C photodetector with a peak spectral sensitivity at 6328 angstroms.

- **LowPass Filter/Voltage Clipper** - This circuit consists of a lowpass frequency passive filter and voltage clipper. The RC time constant is 0.1445  $\Omega\text{F}$  with a cut-off clip voltage of about 3.8 V. The circuit is used to reduce signal noise and prevent a voltage overload condition to the AR11.

- **DR11C**-The DR11C is a digital I/O interface used to position xY-table for scanning interferograms. It is manufactured by DEC and features 16 ports of input and 16 ports of output TTL compatible voltages.

- **XY - Table Controllers** - Control of the XY-Table via the DR11C interface is maintained by these units. This system contains two slo-syn translator modules (Type STM101) manufactured by the Superior Electric Company. Also included in the system are two type MPS-1000 power supplies also made by Superior.

- **XY-table** - The XY-table used to position the interferogram is made by Design Components, Inc., and is a Model DC-66 having a scanning range of 152.4 mm in the x and Y directions. It can take single steps between scan points of 0.0254 mm with a repositioning accuracy of 0.00254 mm.

- **He-Ne laser** - The laser selected was a Spectra-Physics Model 124 He-Ne laser operating at 6328  $\text{\AA}$ .

*Operation of the optical system is controlled through the PDP 11/40 computer. A description and listing of the computer code is contained in the appendix. After the computer program is started, the parameters for performing a raster scan of the interferogram are input*

to the computer through the DECWRITER. A total of 100 points in the x direction and 50 points in the y direction may be scanned for a total of 5000 points. After the scanning parameters are input to the computer, a request is made for the initial position for scanning. The operator then positions the interferogram interactively with the computer. Once this operation is complete the interferogram is scanned by moving it to each scan point automatically and the photodetector intensity signal is digitized by the computer. This entire operation is automatic. If, during the scanning process, the operator needs to stop scanning and return to the initial scan position, the setting of any bit on the control console may perform this function. After the scan is made, a DFT filter operation is performed if requested, and a contour plot of the results is made. While the contour plot is being made, the results can be modified by selecting the proper bit configuration on the computer console. A listing of these commands is contained in the appendix.

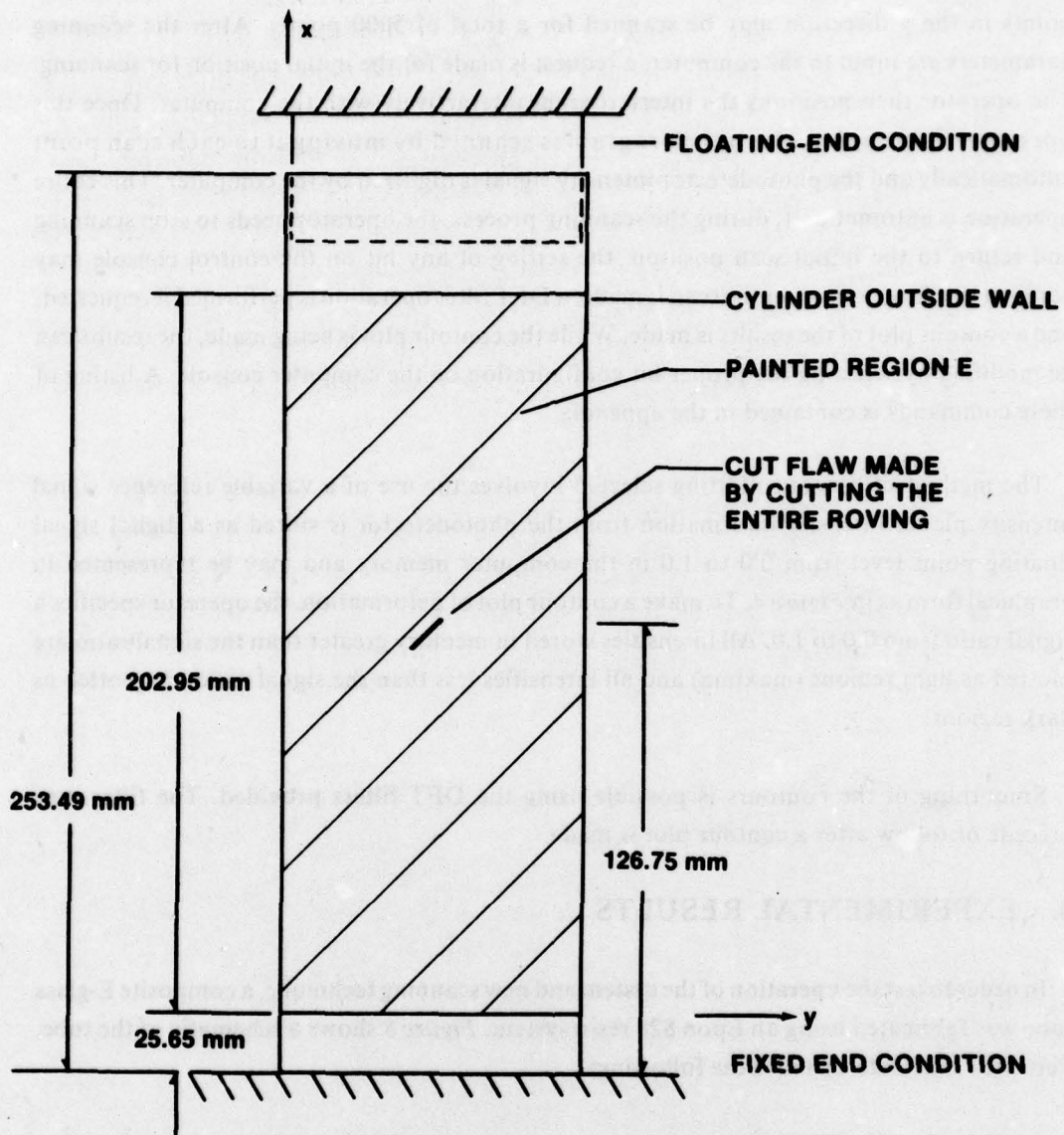
The method of contour plotting selected involves the use of a variable reference signal intensity plane. Intensity information from the photodetector is stored as a digital signal floating point level from 0.0 to 1.0 in the computer memory and may be represented in graphical form as in *Figure 4*. To make a contour plot of deformation, the operator specifies a signal ratio from 0.0 to 1.0. All intensities stored in memory greater than the signal ratio are plotted as light regions (maxima) and all intensities less than the signal ratio are plotted as dark regions.

Smoothing of the contours is possible using the DFT filters provided. The filter may precede or follow after a contour plot is made.

#### 4. EXPERIMENTAL RESULTS

In order to test the operation of the system and new scanning technique, a composite E-glass tube was fabricated using an Epon 828 resin system. *Figure 8* shows a schematic of the tube. Pertinent tube data includes the following:

- Cylinder No. 8-E-45-A
- Test Pressures 0-150 psig
- Cut Fiber Flaw
- E-glass, Epon 828 resin system
- 74.11 mm inside diameter
- 1.27 mm wall thickness
- 76.65 mm outside diameter
- 75.38 mm mean diameter



**Figure 8. - Schematic of tube test specimen.**

The tube had an overall length of 253.49 mm with a cut-flaw in the fiber 126.75 mm from the bottom of the tube. The tube was painted in the region marked E for a total of 202.95 mm. Specimen pressure testing was at 0 and 150 psig. Boundary conditions on the endcaps included a fixed-end condition at the base and a free-floating-end condition at the top of the tube. After pressurizing the tube to 150 psig, a laser photograph was made in the deformed condition and then the pressure was released. A second laser photograph was then made for the double exposure.

Analysis was done with a total of 100 points in the x direction and 50 points in the Y direction. The raster scan included a total of 5000 points. For the scanning process  $\lambda = 152.4$  mm,  $f=255.27$  cm and  $\nu=0.01209$  mm/fringe order. The interferogram scanning increments in x and y covered the entire painted region uniformly. Interferograms of the specimen were analyzed for the front and back surfaces with and without a flaw, respectively.

*Figures 9 and 10* are contour displacement plots of the flawed cylinder surface made with the scanning system. Maxima are indicated with a (-) and minima with an (\*). The horizontal row of numbers indicates the x axis scan position and the vertical column indicates the y axis scan position. The flawed region of the tube is indicated by a broad minima at location column 60, row 25. *Figures 11 and 12* indicate the results after using a DFT Filter. The filter parameters are  $\alpha = 0$  and  $\beta = 14$  in both x and y directions. As seen in *Figures 11 and 12*, there is a significant perturbation in the displacement contour map at the same location as in *Figures 9 and 10*. The results of the filter are to reduce the overall signal noise level. The difference in displacement between a maxima and a minima contour is 0.00605 mm. Therefore, high strain gradients are present in the tube at those locations where displacement contours have sharp changes in the x or y directions.

A series of scans followed by manual fringe digitizations were made and the results compared. In general, the percentage of difference between the automated and manual analysis differed by less than 4% for fringe orders of approximately  $n \approx 1$ . As n approaches values of 4 to 5 the measured displacements differ by less than 2%. The system is very fast and has a potential digitization rate of 6250 data points/min. Under certain optimum conditions  $10^6$  data points may be digitized in about 2 min if the distances between scan points is minimized.

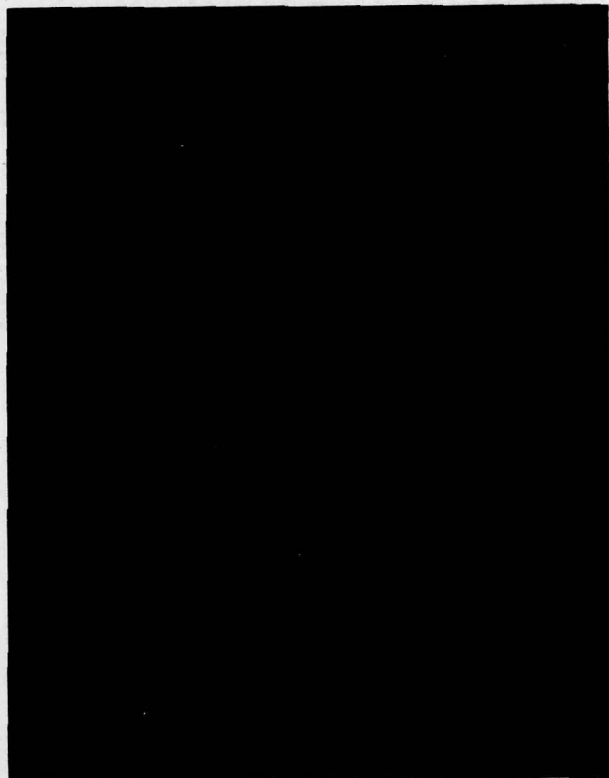
An interesting test was made by plotting on an oscilloscope the intensity map as digitized by the computer and without filtering. *Figure 13* shows the result which may be compared with *Figures 9 and 10*. In this test, a composite tube with a similar flaw as before was analyzed and discontinuities in the fringe pattern can be observed.











**Figure 13. Displacement contour mapping of a flawed composite cylinder.**

## 5. CONCLUSIONS

The theory and an experimental configuration were developed for automated displacement contour analysis of laser speckle interferograms. The number of displacement contours available is proportional to the number of diffraction fringe orders  $n$  available throughout the offset distance  $\lambda$ . The system was checked to determine how well fringe contours could be measured and found to be accurate to at least 4% of the measured distance by hand. System scanning speed is extremely important, and it was found that 5000 data points could be analyzed in about 4 min when the system was operating at about 20% of its maximum rated speed. This is very encouraging for systems in which as many as  $10^6$  data points would be analyzed. Advantages of the present system over those of the past include virtual operator-free scanning, high speed, low cost and full field displacement field mapping.

**APPENDIX**  
**COMPUTER INPUT VARIABLES**

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## 1. CONSOLE CONTROL SWITCHES (PDP 11/40):

- Bit 0 = A new signal ratio will be requested for making a new contour plot immediately if this switch is turned on while a contour plot is being made.
- Bit 1 = A new signal ratio will be requested for making a new contour plot at the end of the current contour plot if this switch is turned on.
- Bit 2 = A new Discrete Fourier Transform filter parameter for filtering the current intensity signal will be requested at the end of the current contour plot if this switch is turned on.
- Bit 3 = If turned on while contour plotting, a new set of scan parameters will be requested at the end of the current contour plot.
- Bit 4 = If turned on while contour plotting, a set of new ASCII code plot symbols will be requested at the end of the current contour plot.
- Bit 5 = If turned on, fringe orders may be ordered to displacement contours at the end of the current contour plot.
- Bit 6 = End the program if turned on while contour plotting. The current contour plot is completed.

## 2. CODE VARIABLES:

IXP = total number of points in the x direction to be scanned.

IXS = number of 0.0254 mm increments between scan points in the x direction.

IYP = total number of points in the y direction to be scanned.

IYS = number of 0.0254 mm increments between scan points in the y direction.

IXF1 =  $\alpha+1$  for the x direction.

IXF2 =  $\beta+1$  for the x direction.

IYF1 =  $\alpha+1$  for the y direction.

IYF2 =  $\beta+1$  for the y direction.

SR = signal ratio.

I1 = number of 0.0254 mm increments to advance the x stage before scanning.

I2 = number of 0.0254 mm increments to advance the y stage before scanning.

### 3. CODE VARIABLES

- IX4 = total number of points in the x direction to be scanned.
- IX2 = number of 0.0254 mm increments between scan points in the x direction.
- IY4 = total number of points in the y direction to be scanned.
- IY2 = number of 0.0254 mm increments between scan points in the y direction.
- IY1 =  $\alpha+1$  for the y direction.
- IY2 =  $\beta+1$  for the y direction.

```

C-----PROGRAM SDFT
C-----WRITTEN BY: JOHN A. SCHAEFFEL, JR.
C-----BIT 0=NEW SR AT END OF PRINT LINE
C-----BIT 1=NEW SR AT END OF CONTOUR PLOT
C-----BIT 2=NEW DFT AT END OF CONTOUR PLOT
C-----BIT 3=NEW SCAN PARAMETERS
C-----BIT 4=NEW ASCII PLOT CODES
C-----BIT 5=EXAMINE FRINGES
C-----BIT 6=END PROGRAM
C-----ALL BITS MUST BE OFF FOR SCAN
C-----0-5 VOLTS AR11 RANGE
C-----INPUT STREAM ON AR11=3
      DIMENSION A(100,50),B(2,100),IT(101)
      KA1=72
      KA2=76
      WRITE(5,1)
1      FORMAT(' SDFT ANALYZER CODE')
41     WRITE(5,2)
2      FORMAT(' NO. X POINTS, X-SCAN INTERVAL-2I3')
      READ(5,3) IXP,IXS
3      FORMAT(2I3)
      WRITE(5,4)
4      FORMAT(' NO. Y POINTS, Y-SCAN INTERVAL-2I3')
      READ(5,3) IYP,IYS
      WRITE(5,11)
11     FORMAT(' DFT X,Y MIN-MAX FILTER LEVELS-4I3')
      READ(5,12) IXF1,IXF2,IYF1,IYF2
12     FORMAT(4I3)
      WRITE(5,13)
13     FORMAT(' SIGNAL RATIO-F10.0')
      READ(5,14) SR
14     FORMAT(F10.0)
10     WRITE(5,36)
36     FORMAT(' X,Y STAGE POSITION-2I4')
      READ(5,37) I1,I2
37     FORMAT(2I4)
      IF(I1.EQ.0.AND.I2.EQ.0) GOTO 38
      CALL XADV(I1,5)
      CALL YADV(I2,5)
      GOTO 10
38     CONTINUE
      IM=0
      IY1=1
      IY2=IYP
      IY3=1
      IXS=IABS(IXS)
      IYS=IABS(IYS)
      DO 6 I=1,IXP,1
      DO 5 J=IY1,IY2,IY3
      CALL IPOKE('170400','21001)
      ITP=IPEEK('170402)
      A(I,J)=FLOAT(ITP)/1024.
      ITEST=IPEEK('177570)
      IF(ITEST.NE.0) GOTO 41
      IF(J.NE.IY2) CALL YADV(IYS,5)
5      CONTINUE
      IY4=IY1
      IY1=IY2
      IY2=IY4
      IY3=-IY3
      IYS=-IYS
      CALL XADV(IXS,5)
6      CONTINUE
      IXS=-IXS

```

```

DO 7 I=1,IXP,1
CALL XADV(IXS,5)
7 CONTINUE
IF(IYS.GT.0) GOTO 9
DO 8 J=1,IYP-1,1
CALL YADV(IYS,5)
8 CONTINUE
9 CONTINUE
IF(IXF1.EQ.0) GOTO 39
IM=0
C=6.283185
D=FLOAT(IXP)
DO 17 J=1,IYP,1
DO 15 I=1,IXP,1
B(1,I)=0.
15 B(2,I)=0.
DO 16 K=IXF1-1,IXF2-1,1
DO 16 L=0,IXP-1,1
B(1,K+1)=B(1,K+1)+(A(L+1,J)*COS(FLOAT(K*L)*C/D))/D
B(2,K+1)=B(2,K+1)-(A(L+1,J)*SIN(FLOAT(K*L)*C/D))/D
16 CONTINUE
DO 17 M=0,IXP-1,1
A(M+1,J)=0.
DO 17 N=IXF1-1,IXF2-1,1
A(M+1,J)=A(M+1,J)+B(1,N+1)*COS(FLOAT(N*M)*C/D)
A(M+1,J)=A(M+1,J)-B(2,N+1)*SIN(FLOAT(N*M)*C/D)
17 CONTINUE
D=FLOAT(IYP)
DO 20 J=1,IXP,1
DO 18 I=1,IYP,1
B(1,I)=0.
18 B(2,I)=0.
DO 19 K=IYF1-1,IYF2-1,1
DO 19 L=0,IYP-1,1
B(1,K+1)=B(1,K+1)+(A(J,L+1)*COS(FLOAT(K*L)*C/D))/D
B(2,K+1)=B(2,K+1)-(A(J,L+1)*SIN(FLOAT(K*L)*C/D))/D
19 CONTINUE
DO 20 M=0,IYP-1,1
A(J,M+1)=0.
DO 20 N=IYF1-1,IYF2-1,1
A(J,M+1)=A(J,M+1)+B(1,N+1)*COS(FLOAT(N*M)*C/D)
A(J,M+1)=A(J,M+1)-B(2,N+1)*SIN(FLOAT(N*M)*C/D)
20 CONTINUE
39 CONTINUE
IF(IM.EQ.0) GOTO 40
WRITE(5,13)
READ(5,14) SR
40 CONTINUE
AMIN=A(1,1)
AMAX=A(1,1)
DO 21 I=1,IXP,1
DO 21 J=1,IYP,1
IF(A(I,J).GT.AMAX) AMAX=A(I,J)
21 IF(A(I,J).LT.AMIN) AMIN=A(I,J)
IF(AMAX.EQ.AMIN) AMAX=AMAX+1.
WRITE(5,22)
22 FORMAT(' DISPLACEMENT FIELD MAP:')
DO 23 I=1,10,1
DO 23 J=1,10,1
23 IT((I-1)*10+J)=J+47
IT(101)=48
WRITE(5,24) (IT(J),J=1,IXP+1,1)
24 FORMAT(1H ,101A1)
DO 25 I=1,IXP,1
25 IT(I)=46
KCR=49

```

```

WRITE(5,26) KCR,(IT(J),J=1,IXP,1)
26  FORMAT(1H ,1A1,100A1)
DO 33 I=IYP-1,2,-1
KCR=KCR+1
DO 31 M=2,IXP-1,1
31  IT(M)=46
DO 32 J=2,IXP-1,1
A1=(A(J,I)-AMIN)/(AMAX-AMIN)
IF(A1.GT.SR) IT(J)=KA1
32  IF(A1.LE.SR) IT(J)=KA2
WRITE(5,26) KCR,(IT(J),J=1,IXP,1)
IF(KCR.EQ.57) KCR=47
IM=0
ITEST=IPEEK('177570)
IF(ITEST.NE.0) IM=1
IF(ITEST.EQ.1) GOTO 39
33  CONTINUE
DO 34 I=1,IXP,1
34  IT(I)=46
KCR=KCR+1
WRITE(5,26) KCR,(IT(J),J=1,IXP,1)
IF(ITEST.EQ.2) GOTO 39
IM=0
IF(ITEST.EQ.4) WRITE(5,11)
IF(ITEST.EQ.4) READ(5,12) IXF1,IXF2,IYF1,IYF2
IF(ITEST.EQ.4) GOTO 9
IF(ITEST.EQ.8) GOTO 41
IF(ITEST.EQ.16) WRITE(5,42)
42  FORMAT(' HIGH, LOW ASCII CODES-2I2')
IF(ITEST.EQ.16) READ(5,43) KA1,KA2
43  FORMAT(2I2)
IF(ITEST.EQ.16) GOTO 40
IF(ITEST.EQ.64) GOTO 35
IF(ITEST.NE.32) GOTO 10
IBX=1
IBY=IYP
IXS=IABS(IXS)
IYS=IABS(IYS)
44  WRITE(5,45)
45  FORMAT(' X,Y INPUT POSITION-2I3')
READ(5,3) IZX,IZY
I1=(IZX-IBX)*IXS
I2=-(IZY-IBY)*IYS
IF(I1.NE.0) CALL XADV(I1,5)
IF(I2.NE.0) CALL YADV(I2,5)
IBX=IZX
IBY=IZY
IF(IZX.NE.1.OR.IZY.NE.IYP) GOTO 44
GOTO 10
35  CONTINUE
STOP
END
SUBROUTINE XADV(IS,IR)
X=0.
IF(IS.GT.0) GOTO 3
IP=IABS(IS)
DO 2 I=1,IP,1
CALL IPOKE('167772','100000)
DO 7 K=1,IR,1
7  Y=SIN(X)
CALL IPOKE('167772','000000)
DO 1 J=1,IR,1
1  Y=SIN(X)
2  CONTINUE
GOTO 6
3  CONTINUE

```

```

DO 5 II=1,IS,1
CALL IPOKE('167772','040000)
DO 8 KK=1,IR,1
8 Y=SIN(X)
CALL IPOKE('167772','000000)
DO 4 JJ=1,IR,1
4 Y=SIN(X)
5 CONTINUE
6 CONTINUE
RETURN
END
SUBROUTINE YADV(IS,IR)
X=0.
IF(IS.GT.0) GOTO 3
IP=IABS(IS)
DO 2 I=1,IP,1
CALL IPOKE('167772','020000)
DO 7 K=1,IR,1
7 Y=SIN(X)
CALL IPOKE('167772','000000)
DO 1 J=1,IR,1
1 Y=SIN(X)
2 CONTINUE
GOTO 6
3 CONTINUE
DO 5 II=1,IS,1
CALL IPOKE('167772','010000)
DO 8 KK=1,IR,1
8 Y=SIN(X)
CALL IPOKE('167772','000000)
DO 4 JJ=1,IR,1
4 Y=SIN(X)
5 CONTINUE
6 CONTINUE
RETURN
END
*
```

## LIST OF SYMBOLS

Symbol	Definition
$C_n$	Discrete Fourier transform frequency spectral components
$2d$	Spacing between $n = 1/2$ fringe orders
$dv$	Vertical vectoral component of $d$
$dH$	Horizontal vectoral component of $d$
$f$	Distance from interferogram to analyzer screen
$I(K)$	Digitized intensity data
$I'(K)$	Filtered intensity data
$J$	Imaginary number
$N$	Total number of data samples
$n$	Fringe order of contour
$S$	Film scale factor
$U_\theta$	Absolute displacement along $\theta$ axis
$U_v$	Absolute displacement along vertical axis
$U_H$	Absolute displacement along horizontal axis
$\alpha$	Lower harmonic level of DFT filter

$\beta$	Upper harmonic level for DFT filter
$\lambda$	Wavelength of laser light source
$\theta$	Angle
$\nu$	Optical geometrical constant
$\chi$	Photodetector offset distance

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